

Adjusting Device Temperature Measurement using a Thermocouple Probe Card

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Nidec SV Probe

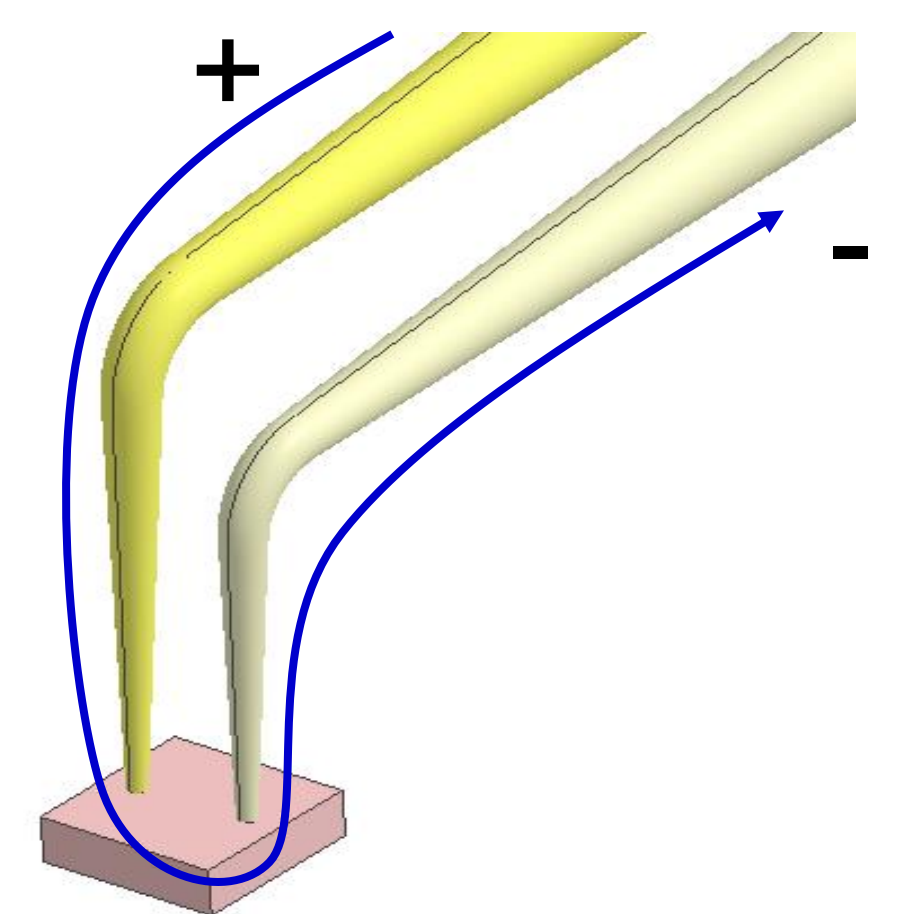
ABSTRACT

Adjusting Device Temperature Measurement using a Thermocouple Probe Card

In a test environment, temperature distribution across the wafer can cause issues due to varying test temperature between the chips. Without temperature sensors integrated into the device, it is necessary to perform chip temperature measurements with the probe card and adjust those measurements on the fly based on the results.

We will explore this temperature measurement challenge and how a probe card developed with thermocouple functionality can be utilized to make measurement decisions faster and easier.

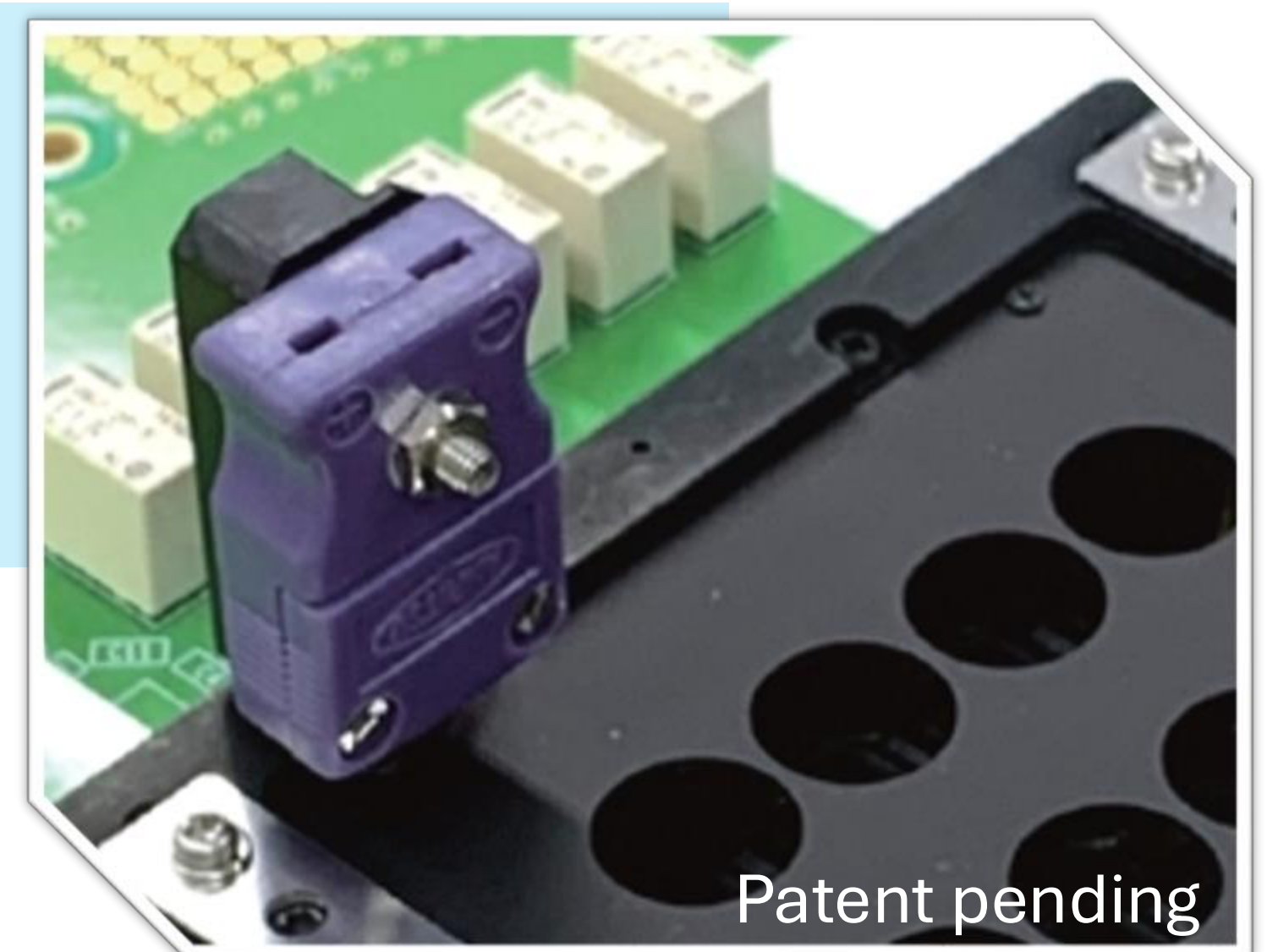
We will also discuss the results from our evaluations of temperature measurement accuracy.



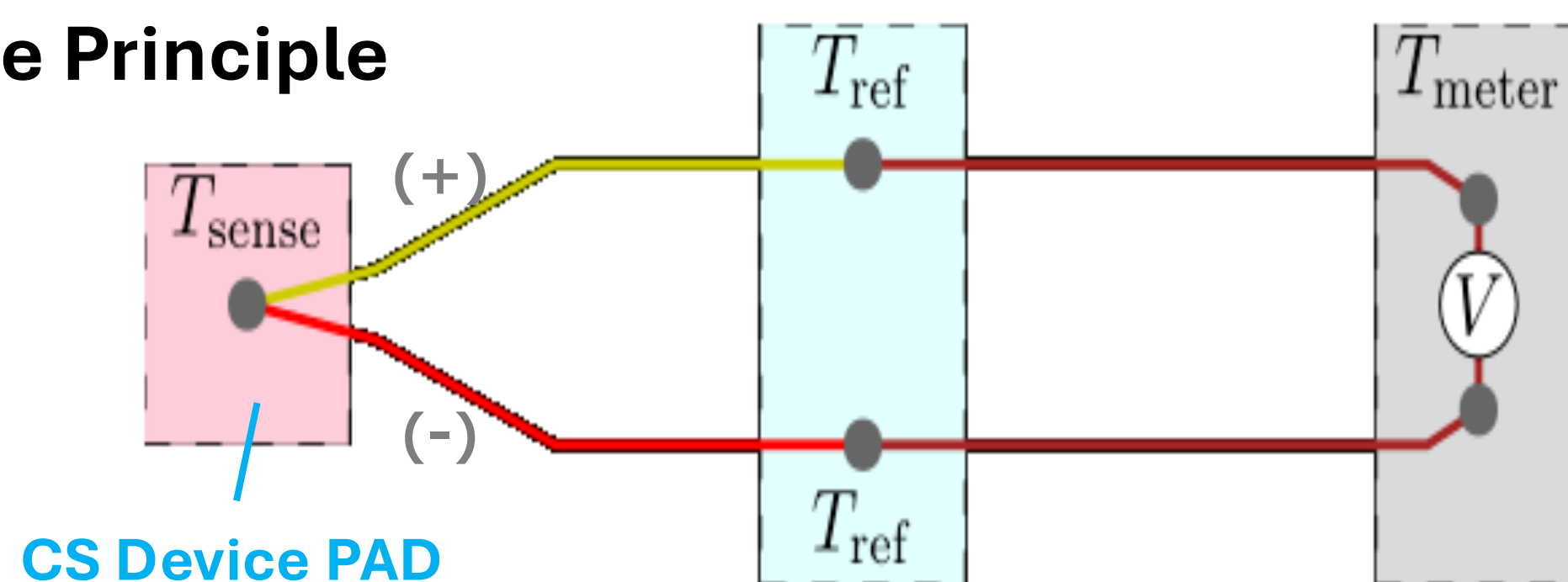
- ✓ On the fly measurement of the actual chip temperature during device operation
- ✓ Measurement of temperature distribution in the wafer surface
- ✓ Calibration of prober chuck temperature

The Concept of TC (Thermocouple) Probe Card ①

- Type E, Class 1
- Range : -40°C~200°C
- Accuracy : ±1.5°C (Type E nature accuracy)
- Requirement.1 Customer must have Type E data logger

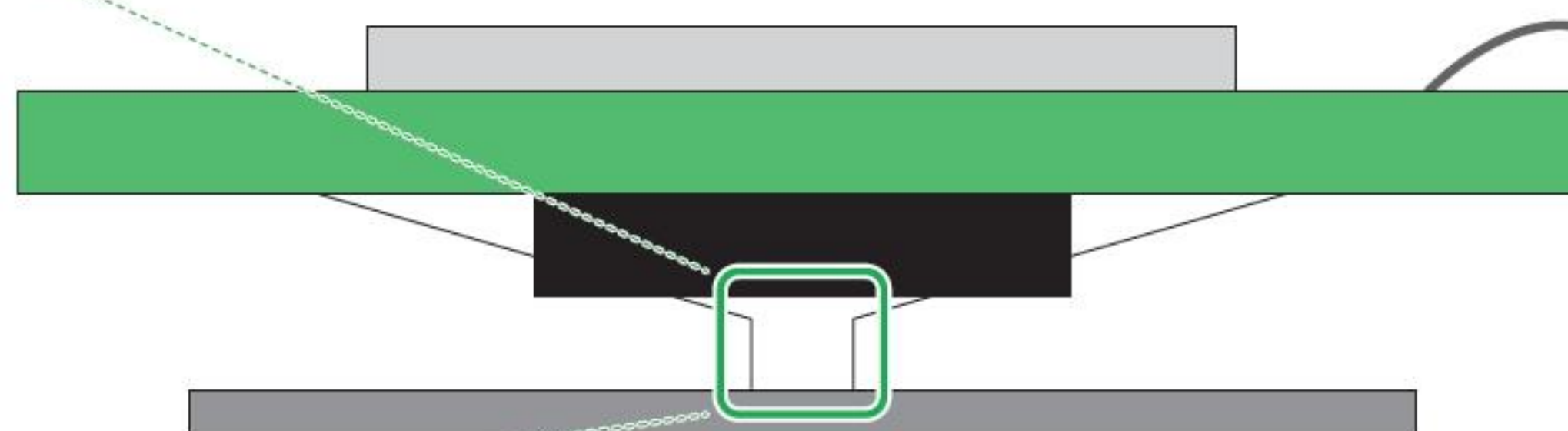
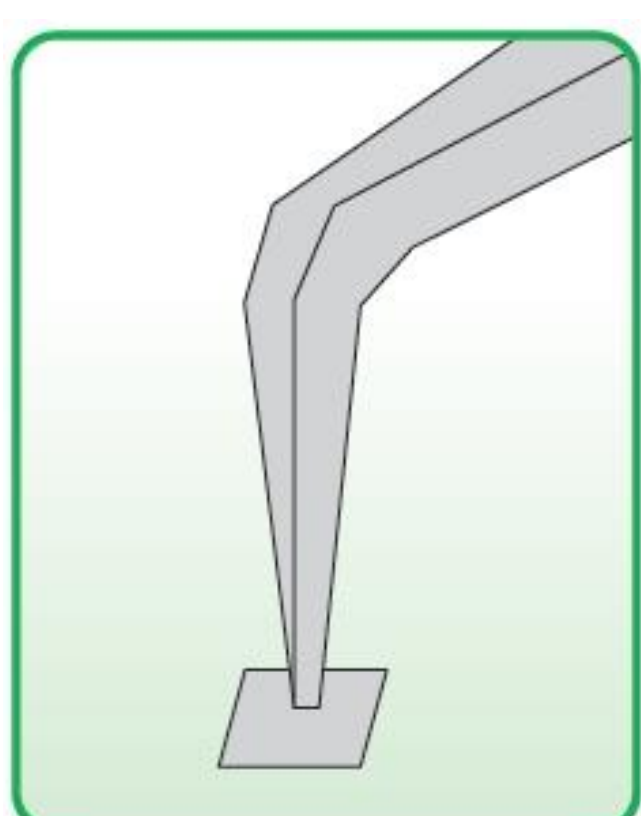


TC Probe Principle



Result to tester
• WiFi
• GPIB

Card Configuration



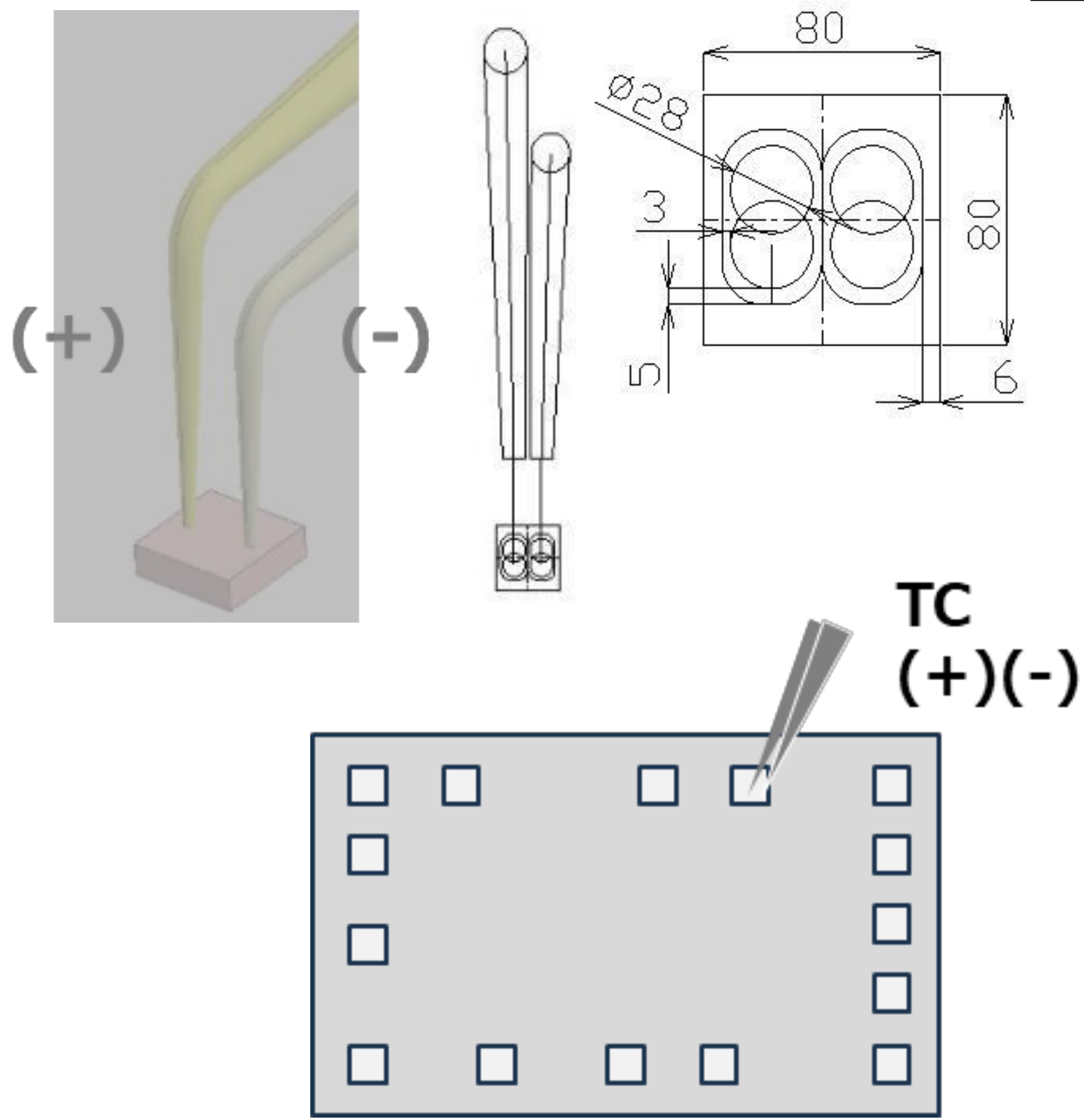
Device Temperature Measurement Card Structure

Data Logger (Prepared by customer)

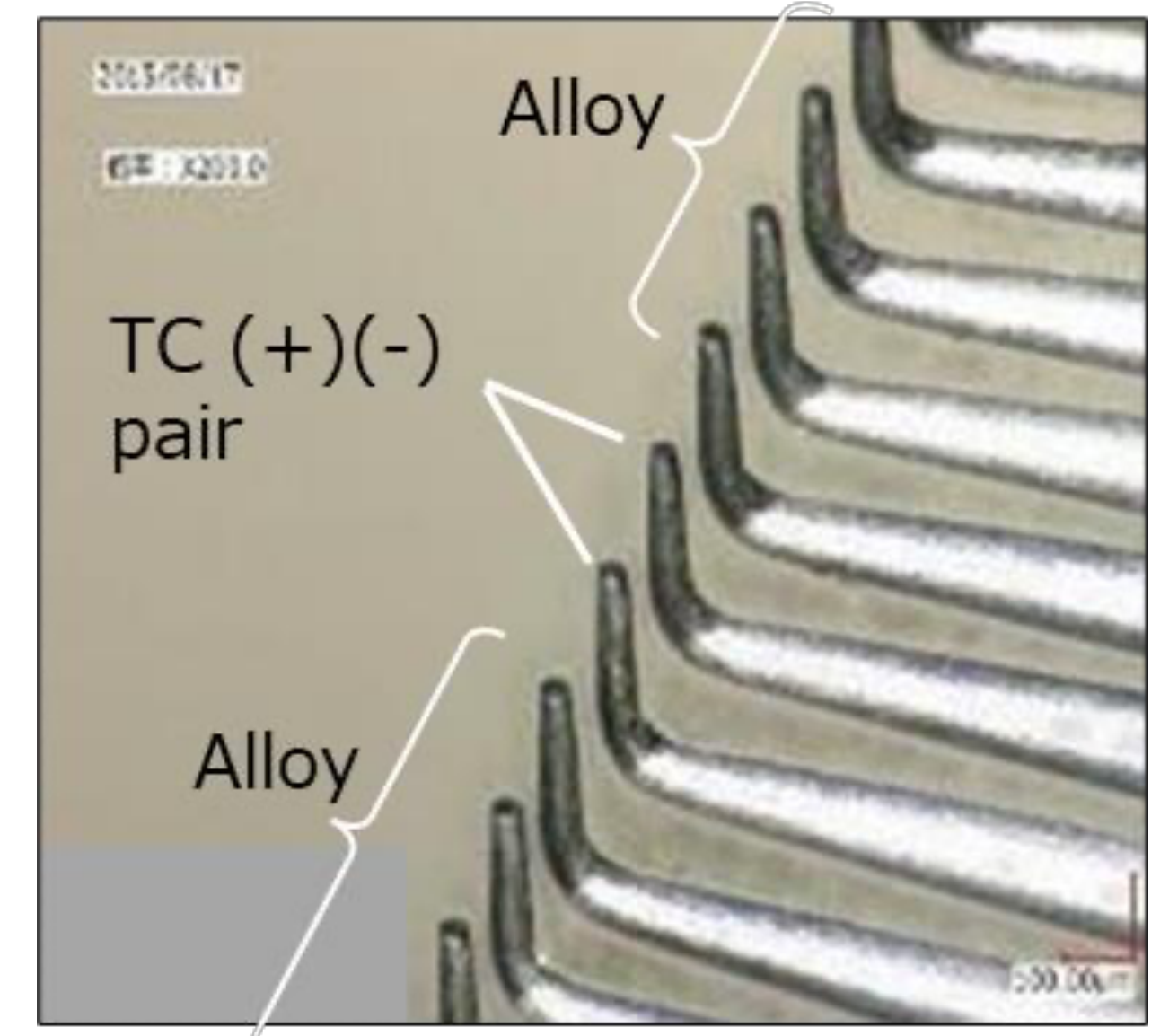
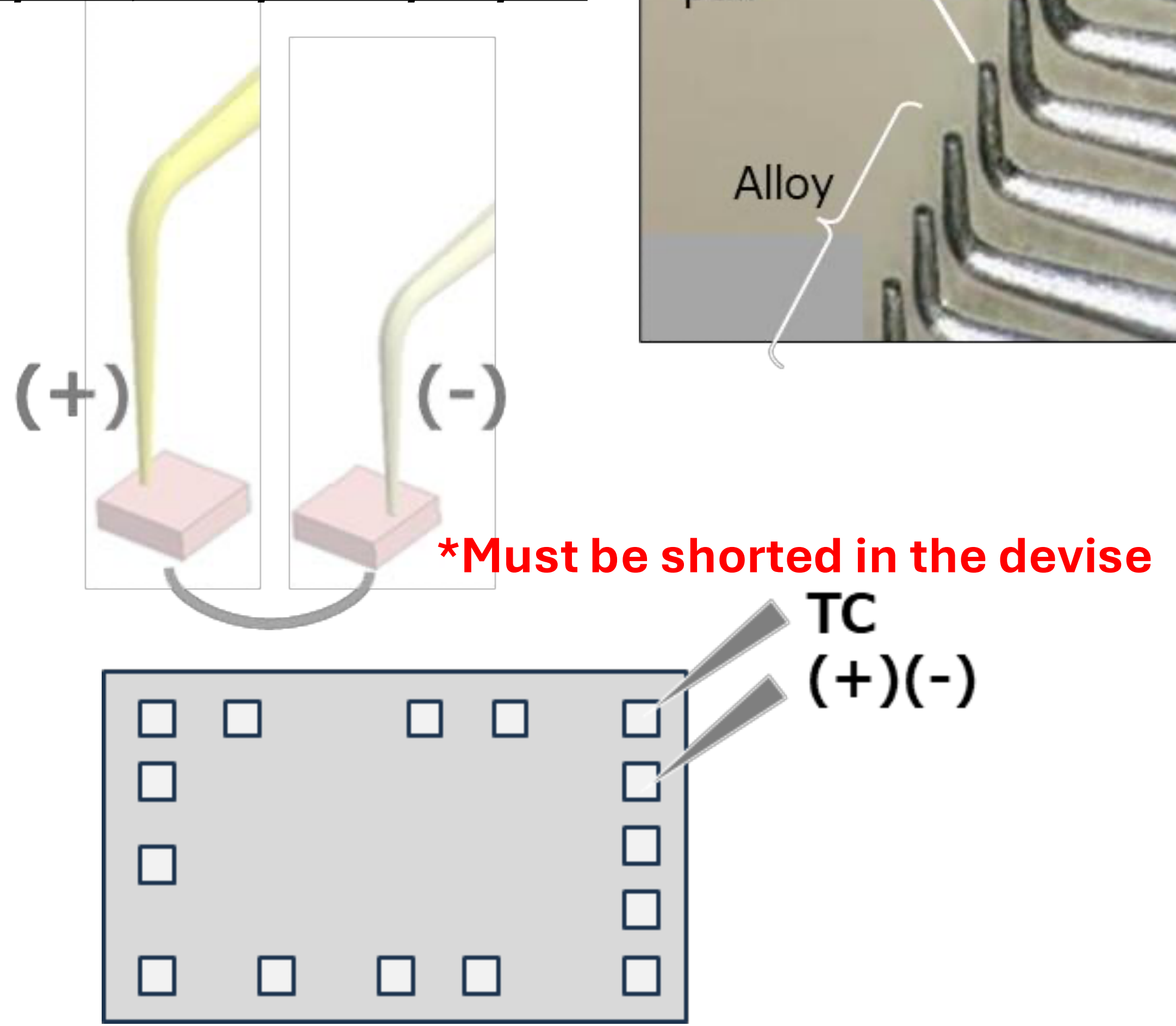
The Concept of TC (Thermocouple) Probe Card ②

- Signal, Power and GND Metal Alloy probe
- Dummy pad or any pad TC Probe

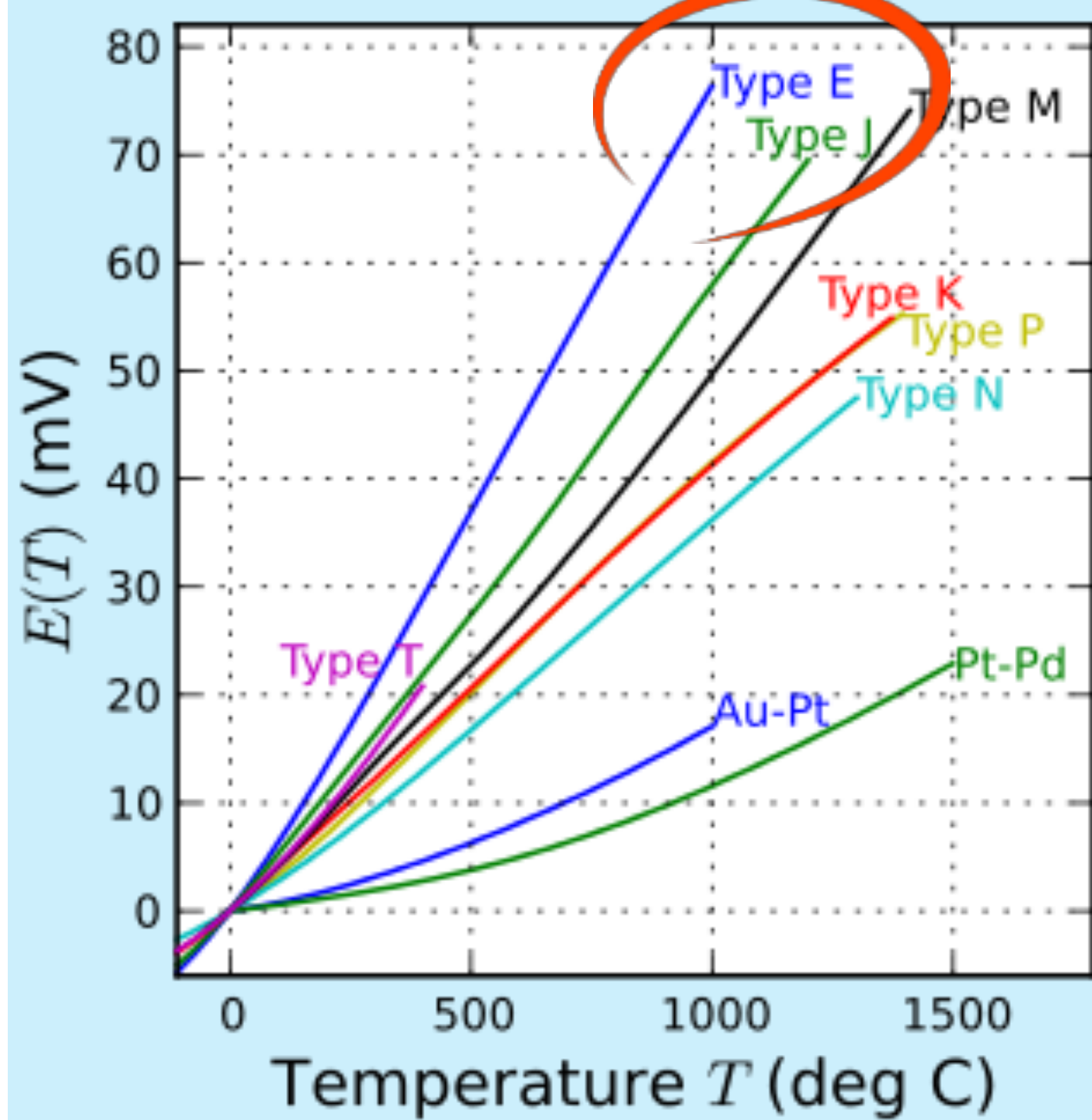
One pad, two probes



Two pads, one probe per pad



Thermocouple Type E general specification



Thermocouple Type E Technical Details

Thermocouple E type has a very high EMF output of $68 \mu\text{V}/^\circ\text{C}$ which provides a strong signal for instrumentation and a high accuracy. Type E is also non-magnetic. It is very rare thermocouple type and is not used as much as the other types of thermocouple.

Type E Thermocouple Temperature Range

Continuous:
0 to $+800^\circ\text{C}$
Short Term:
 -40 to $+900^\circ\text{C}$

Type E Thermocouple Material

Chromel
Constantan

Type E Thermocouple Tolerance Details

Tolerance Class 1

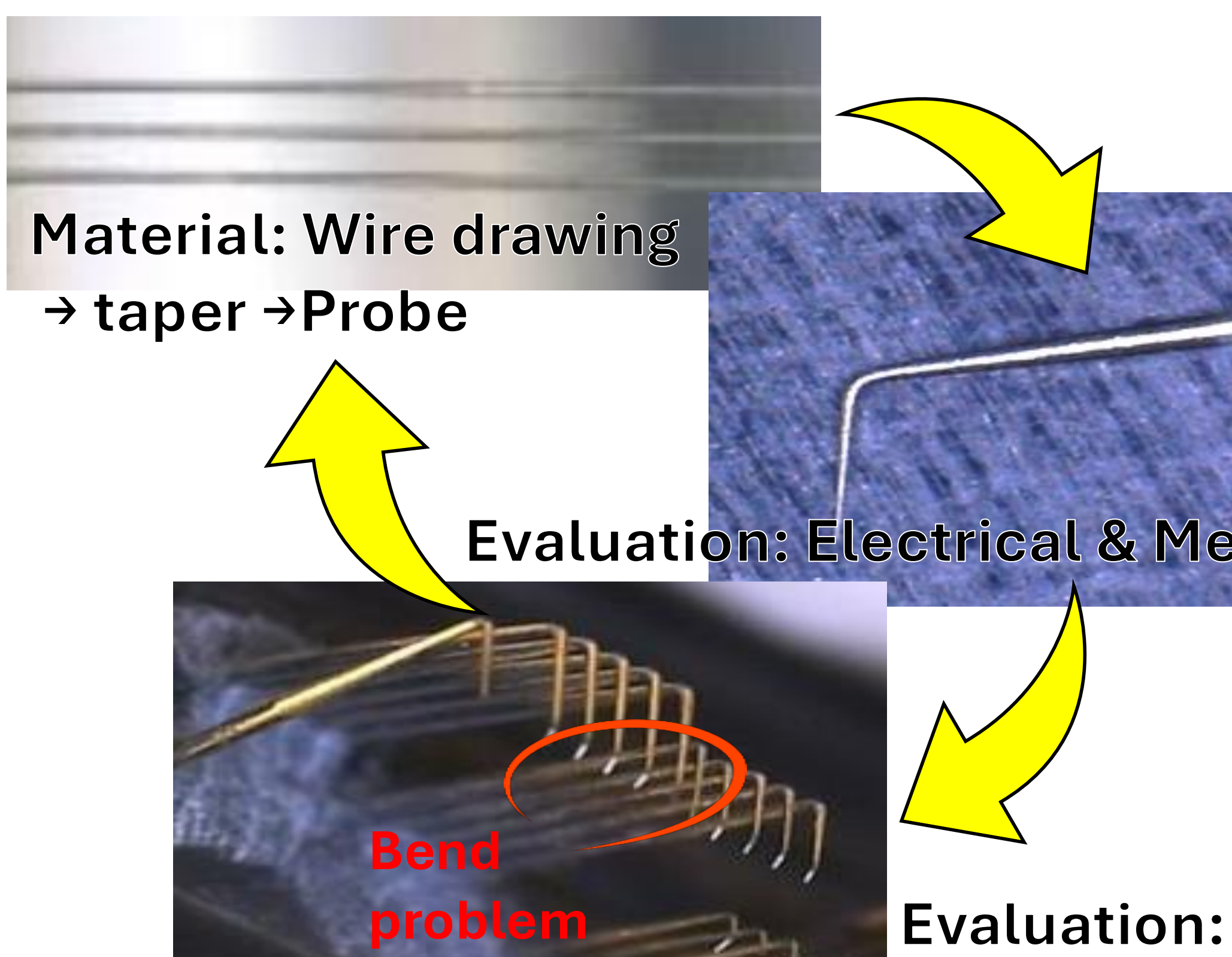
-40 to $+375 \pm 1.5^\circ\text{C}$
 375 to $800 \pm 0.004[t]^\circ\text{C}$

Tolerance Class 2

-40 to $+333 \pm 2.5^\circ\text{C}$
 333 to $900 \pm 0.0075[t]^\circ\text{C}$

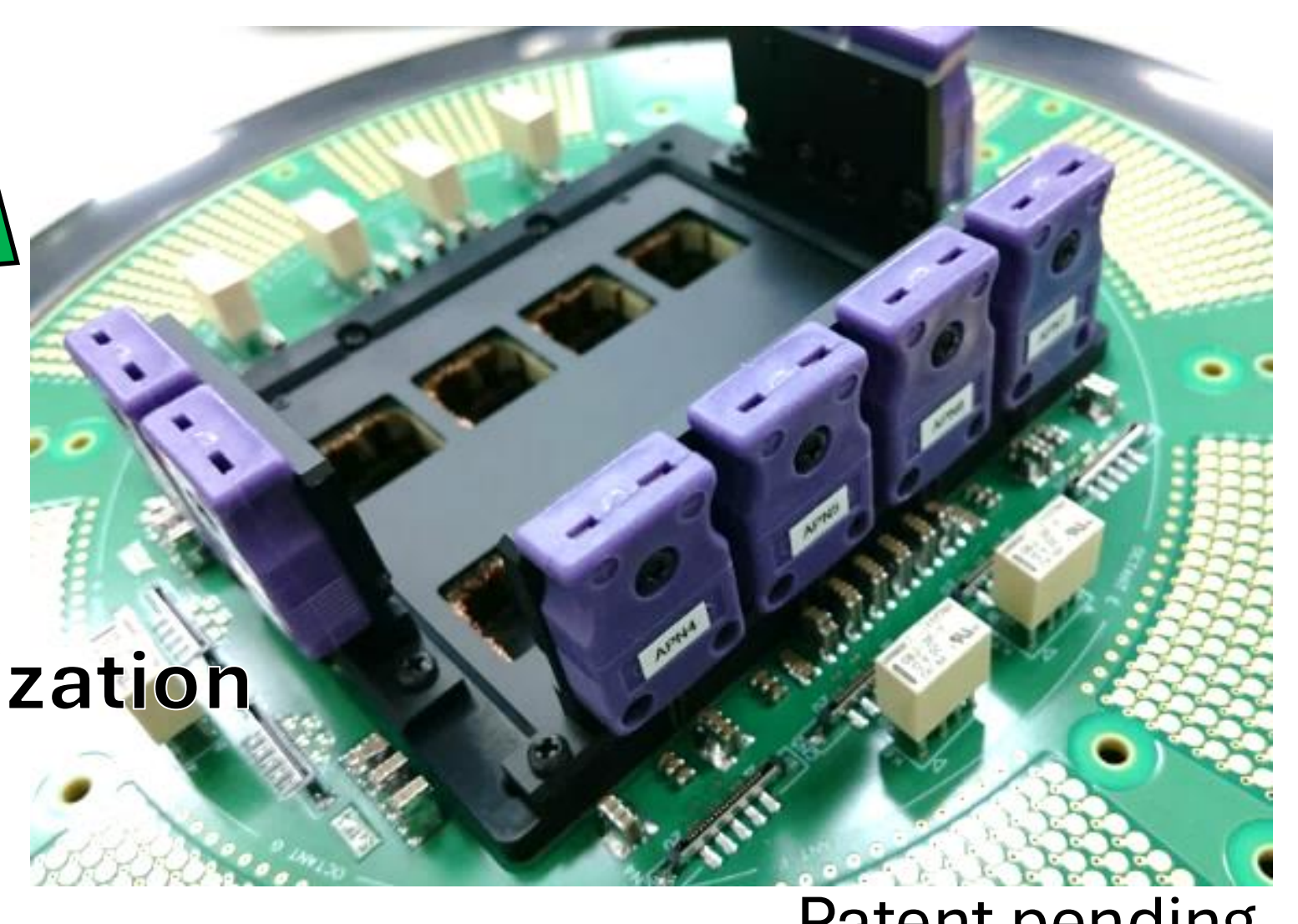
SV – TC(Thermocouple) Probe

• Evaluation process



Objective

- Temp. measurement accuracy
- Basic requirement as cantilever probe material
- Basic requirement as the probe card



Evaluation: TC Probe Meas. Wafer Temp. distribution

Chuck Temp. : Set -40°C

Center	CH 1	-40.5 $^{\circ}\text{C}$
	CH 2	-40.5 $^{\circ}\text{C}$
Edge	CH 3	Distribution -37.9 $^{\circ}\text{C}$
	CH 4	$\Delta 2.6^{\circ}\text{C}$
	CH 5	-39.0 $^{\circ}\text{C}$
	CH 6	-39.1 $^{\circ}\text{C}$

SV probe lab.

UF3000-EX prober

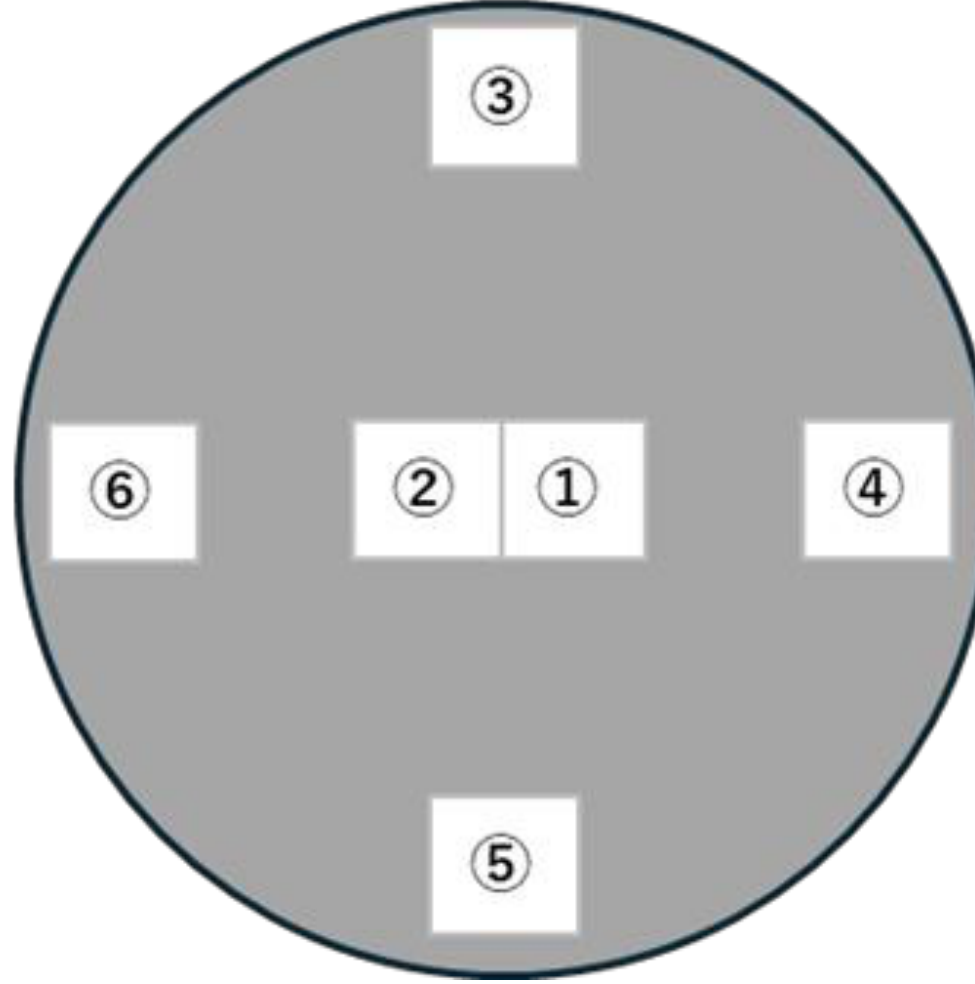
- STD chuck
- $\Phi 300\text{mm}$ Al WF 800um thickness
- Wait time 30 minutes
- Meas. 6 locations on WF

Chuck temp : Set 100°C

Center	CH 1	99.1 $^{\circ}\text{C}$
	CH 2	99.0 $^{\circ}\text{C}$
Edge	CH 3	Distribution 97.0 $^{\circ}\text{C}$
	CH 4	$\Delta 2.1^{\circ}\text{C}$
	CH 5	98.2 $^{\circ}\text{C}$
	CH 6	97.2 $^{\circ}\text{C}$

Chuck temp : Set 0°C

Center	CH 1	-0.8 $^{\circ}\text{C}$
	CH 2	-0.8 $^{\circ}\text{C}$
Edge	CH 3	Distribution 0.8 $^{\circ}\text{C}$
	CH 4	$\Delta 1.6^{\circ}\text{C}$
	CH 5	0.6 $^{\circ}\text{C}$
	CH 6	0.3 $^{\circ}\text{C}$



Chuck temp : Set 150°C

Center	CH 1	148.9 $^{\circ}\text{C}$
	CH 2	148.6 $^{\circ}\text{C}$
Edge	CH 3	Distribution 144.8 $^{\circ}\text{C}$
	CH 4	$\Delta 4.1^{\circ}\text{C}$
	CH 5	145.3 $^{\circ}\text{C}$
	CH 6	147.1 $^{\circ}\text{C}$

- ☞ SV Lab prober UF3000-EX, observed some Δ
- ☞ WF edge Δ is larger than the middle

Summary

Adjusting Device Temperature Measurement using a Thermocouple Probe Card

- ✓ On the fly measurement of the actual chip temperature during device operation
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Utilized Thermocouple Type E to match with metal alloy probe

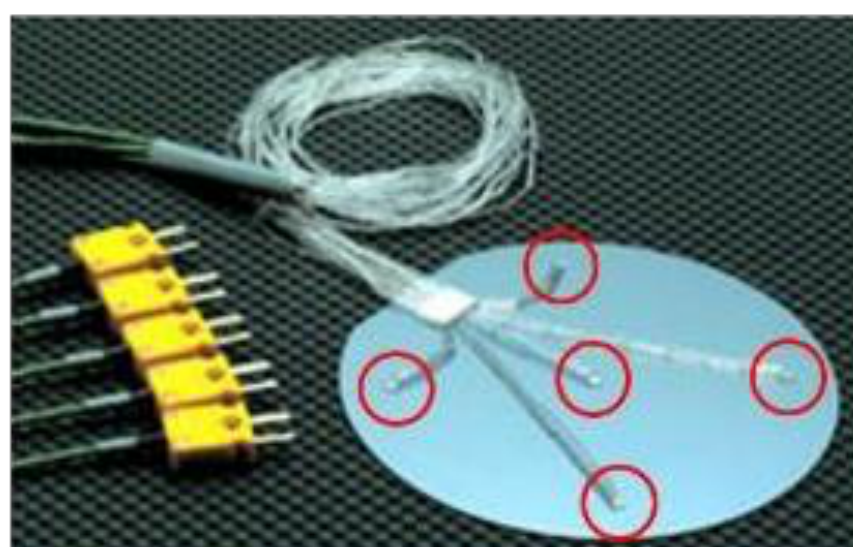
- ✓ Accuracy $\pm 1.5^{\circ}\text{C}$ from native Type E specification
- ✓ Min pitch 70um
- ✓ 1.8gf@60umOD
- ✓ Temp. -40 to $+200^{\circ}\text{C}$

Requirement

- ✓ TC probe touchdown on one pad or two pads connected in device
- ✓ Interface to Data logger on PCB top
- ✓ Data logger

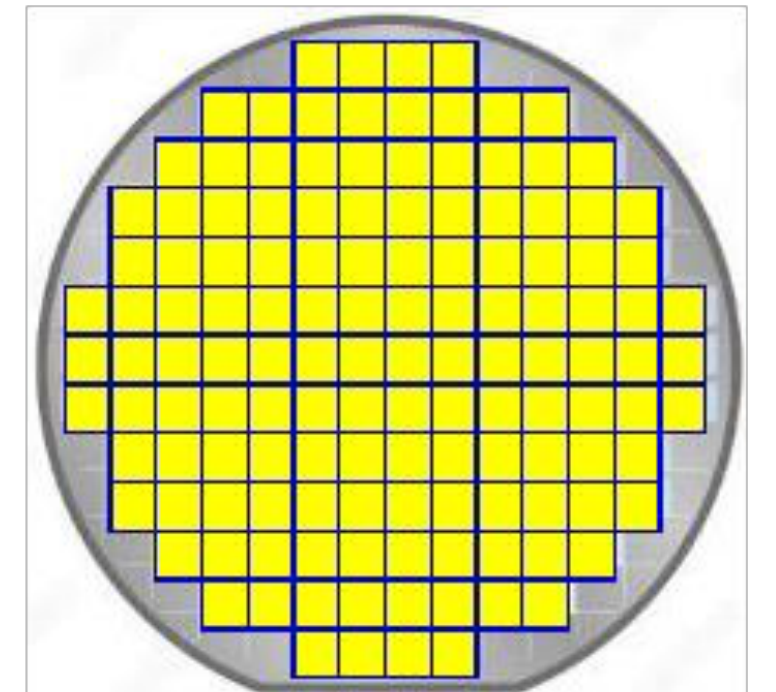
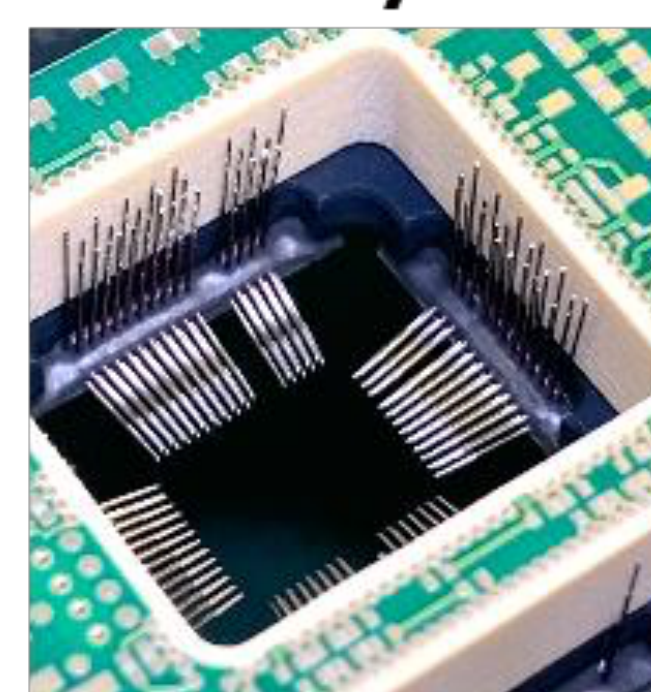
•In general

Ta = Prober Chuck Temp. = Prober Set
Tj = Never know
Preparation → Maintenance data w Dummy WF



•TC Probe advantage

Tj = Measure it on the fly every TD



Contact

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